

<b>Notice of References Cited</b>	Application/Control No. 10/713,508	Applicant(s)/Patent Under Reexamination LIN, WEN-JIAN	
	Examiner John A. McPherson	Art Unit 1756	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0218251	11-2004	Piehl et al.	359/290
*	B	US-2004/0209192	10-2004	Lin et al.	430/311
	C	US-			
	D	US-			
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**FOREIGN PATENT DOCUMENTS**

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